



Image Rce 12825 \$

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

**MAIL STOP RCE**

Satoshi TANAKO

Group Art Unit: 2825

Application No.: 09/819,690

Examiner: G. Lee

Filed: March 29, 2001

Docket No.: 109107

For: SEMICONDUCTOR, MANUFACTURING METHOD, SUBSTRATE PROCESSING METHOD, AND SEMICONDUCTOR MANUFACTURING APPARATUS

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant hereby requests continued examination.

☒ Applicant further requests entry and consideration of the submission filed October 3, 2003.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 149823 in the amount of ☒ \$770.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,

*Phillip D. Mancini*

James A. Oliff  
Registration No. 27,075

Phillip D. Mancini  
Registration No. 46,743

01/06/2004 JADD01 00000105 09819690

01 FC:1801 770.00 DP

JAO:PDM/ccs

Date: January 5, 2004

OLIFF & BERRIDGE, PLC  
P.O. Box 19928  
Alexandria, Virginia 22320  
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE  
AUTHORIZATION**  
Please grant any extension  
necessary for entry;  
Charge any fee due to our  
Deposit Account No. 15-0461